

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: FORREST, et al.

SERIAL NO.: 10/581,622 GROUP ART UNIT: 1794

FILED: June 5, 2006 EXAMINER: Nelson, Michael B.

FOR: FREE-STANDING SILICON CARBIDE ARTICLES FORMED
BY CHEMICAL VAPOR DEPOSITION AND METHODS FOR
THEIR MANUFACTURE

ATTORNEY DOCKET NO.: 52993/326894
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Commissioner for Patents
P.O. Box 1450
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CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being filed with
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on June 23, 2008.

/Melody Wilson/
Melody Wilson

RESPONSE TO RESTRICTION REQUIREMENT

Madam:

In response to the Office Action of May 23, 2008, Applicants respectfully submit the following remarks in connection with this application.

Remarks begin on page 2 of this paper.